S/N10/720,409confirmation no. 5057ApplicantResponse to Office Action dated 2006-09-25

Attorney Docket: CS03-039

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To:	Commissioner of Patents	
	P.O. Box 1450	
	Alexandria, VA	22313-1450

From:	William J. Stoffel	
	Reg no. 39,390	
	Customer no. 30,402	

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Subject:

S/N 10/ 720,409 Inventor Feng Chen Confirmation no. 5057 Attorney Docket: CS03-039

File date: 11/24/2003

Title : CMP Polishing Heads Retaining Ring Groove Design for Microscratch Reduction

Group Art Unit: 3723 Examiner: Shakeri

RESPONSE UNDER 37 CFR 1.116- EXPIDITED PROCEDURE – EXAM GROUP 3723-

RESPONSE TO OFFICE ACTION DATED 2006-09-25

Dear Sir:

Enclosed is a Response to Office Action dated 2006-09-25. Please consider the

following remarks:

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION Total 28 Pages in this Fax

I hereby certify that this correspondence is being : [_] FAXED to the central facsimile number of patent and trademark office at the following number (571) 273-8300 or [_] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450; on the date below.

Signature /William J. Stoffel/
William J. StoffelDATE November 27, 2006
Reg. No. 39,390Customer number 30402

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This response to Office Action has the following sections:

- AMENDMENTS TO THE CLAIMS are reflected in the listing of claims that begin on the next page (p. 3)
- **REMARKS/ARGUMENTS** begin on the page following the previous section (p. 10)